## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KANNO et al.

Art Unit: Unassigned

Application No. Unassigned

Examiner: Unassigned

Filed: July 11, 2003

For:

CLEANING COMPOSITION FOR

REMOVING RESISTS AND

MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE

## PRELIMINARY AMENDMENT

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.

In re Appln. of KANNO et al. Application No. Unassigned

## IN THE TITLE:

Replace the title with:

CLEANING COMPOSITION FOR REMOVING RESISTS AND <u>METHOD OF</u> MANUFACTURING <del>METHOD OF</del> SEMICONDUCTOR DEVICE